Ma	ALITAL COAC	TIA Products in AHTN 2012
No	AHTN 2012	Description
1	3818.00.00	Chemical elements doped for use in electronics, in the form of discs, wafers or similar forms; chemical compounds doped for use in electronics.
2	7017.10.10	Quartz reactor tubes and holders designed for insertion into diffusion and oxidation furnaces for production of semiconductor wafers
3	7020.00.20	 Quartz reactor tubes and holders designed for insertion into diffusion and oxidation furnaces for production of semiconductor wafers
4	8419.39.11	Machinery for the treatment of materials by a process involving heating, for the manufacture of printed circuit boards, printed wiring boards or printed circuit assemblies
	8419.89.13	Machinery for the treatment of material by a process involving heating, for the manufacture of printed circuit boards, printed wiring boards or printed circuit assemblies
6	8419.89.19	Other
7	8420.10.10	Apparatus for the application of dry film or liquid photo resist, photo-sensitive layers, soldering pastes, solder or adhesive materials on printed circuit boards or printed wiring boards or their components
8	8420.91.10	Parts of apparatus for the application of dry film or liquid photo resist, photo sensitive layers, soldering pastes, solder or adhesive materials on printed circuit boards or printed wiring boards substrates or their components
9	8420.99.10	Parts of apparatus for the application of dry film or liquid photo resist, photo sensitive layers, soldering pastes, solder or adhesive materials on printed circuit boards or printed wiring boards substrates or their components
10	8424.89.40	Wet processing equipment, by projecting, dispersing or spraying, of chemical or electrochemical solutions for the application on printed circuit boards or printed wiring boards substrates; apparatus for the spot application of liquids, soldering pastes, solder ball, adhesives or sealant to printed circuit boards or printed wiring boards or their components; apparatus for the application of dry film or liquid photo resist, photo sensitive layers, soldering pastes, solder or adhesive materials on printed circuit boards or printed wiring boards substrates or their components
11	8428.20.20	Automated machines for the transport, handling and storage of printed circuit boards, printed wiring boards or printed circuit assemblies
12	8428.33.20	Automated machines for the transport, handling and storage of printed circuit boards, printed wiring boards or printed circuit assemblies

Na	ALITNI 2042	TIA Products in AHTN 2012
No	AHTN 2012	Description
13	8428.39.30	Automated machines for the transport, handling and storage of printed circuit boards, printed wiring boards or printed circuit
		assemblies
		Automated machines for the transport, handling and storage of
14	8428.90.20	printed circuit boards, printed wiring boards or printed circuit
	0 120100120	assemblies
		Of automated machines for the transport, handling and storage
15	8431.39.40	of printed circuit boards, printed wiring boards or printed circuit
'	0 10 1.00. 10	assemblies
16	8443.19.00	Other
	8443.31.10	Printer-copiers, printing by the ink-jet process
	8443.31.20	Printer-copiers, printing by the laser process
	8443.31.30	Combination printer-copier-facsimile machines
	8443.31.90	Other
	8443.32.10	Dot matrix printers
	8443.32.20	
	8443.32.30	Ink-jet printers
		Laser printers
	8443.32.40	Facsimile machines
25	8443.32.50	Screen printing machinery for the manufacture of printed circuit boards or printed wiring boards
26	8443.32.60	Plotters
	8443.32.90	Other
	8443.39.11	Colour
_	8443.39.19	Other
	0110.00.10	Electrostatic photocopying apparatus, operating by reproducing
30	8443.39.20	the original image via an intermediate onto the copy (indirect
	0110100120	process)
	0.4.40.00.00	· · · · · · · · · · · · · · · · · · ·
31	8443.39.30	Other photocopying apparatus incorporating an optical system
32	8443.99.10	Of screen printing machinery for the manufacture of printed
52	0440.00.10	circuit boards or printed wiring boards
33	8443.99.20	Ink-filled printer cartridges
34	8443.99.30	Paper feeders and sorters
35	8443.99.90	Other
		Machine tools, numerically controlled, for working any material by
36	8456.90.10	removal of material, by plasma arc processes, for the manufacture of
		printed circuit boards or printed wiring boards
		Wet processing equipments for the application by immersion of
37	8456.90.20	electro-chemical solutions, for the purpose of removing material on
		printed circuit boards or printed wiring boards
38	ex8456.90.90	Water-jet cutting machines
		Machine tools, numerically controlled, for sharpening carbide
39	8460.31.10	drilling bits with a shank diameter not exceeding 3.175 mm, provided
		with fixed collets and having a power not exceeding 0.74 kW
		The same to the same that the

No	AHTN 2012	Description
NO	AITIN 2012	Of a kind used for scoring printed circuit boards or printed wiring
40	8465.91.10	boards or printed circuit board or printed wiring board substrates, electrically operated
41	8465.92.10	For routing printed circuit boards or printed wiring boards or printed circuit board or printed wiring board substrates, accepting router bits with a shank diameter not exceeding 3.175 mm, for scoring printed circuit boards or printed wiring boards or printed circuit board or printed wiring board substrates
42	8465.95.10	Drilling machines for the manufacture of printed circuit boards or printed wiring boards, with a spindle speed exceeding 50,000 rpm and accepting drill bits of a shank diameter not exceeding 3.175 mm
43	8465.99.50	Machines for deburring the surfaces of printed circuit boards or printed wiring boards during manufacturing; machines for scoring printed circuit boards or printed wiring boards or printed circuit board or printed wiring board substrates; laminating presses for the manufacture of printed circuit boards or printed wiring boards
44	8466.10.10	For the machine-tools of subheading 8456.90.10, 8456.90.20, 8460.31.10, 8465.91.10, 8465.92.10, 8465.95.10 or 8465.99.50
45	8466.20.10	For the machine-tools of subheading 8456.90.10, 8456.90.20, 8460.31.10, 8465.91.10, 8465.92.10, 8465.95.10 or 8465.99.50
46	8466.30.10	For the machine-tools of subheading 8456.90.10, 8456.90.20, 8460.31.10, 8465.91.10, 8465.92.10, 8465.95.10 or 8465.99.50
47	8466.92.10	For the machine tools of subheading 8465.91.10, 8465.92.10, 8465.95.10 or 8465.99.50
48	8466.93.20	For machines of subheading 8456.90.10, 8456.90.20 or 8460.31.10
49	8466.94.00	For machines of heading 84.62 or 84.63
50	8469.00.10	- Word-processing machines
51	8470.10.00	- Electronic calculators capable of operation without an external source of electric power and pocket-size data recording, reproducing and displaying machines with calculating functions
52	8470.21.00	Incorporating a printing device
	8470.29.00	Other
	8470.30.00	- Other calculating machines
	8470.50.00	- Cash registers
	8470.90.10	Postage-franking machines
-	8470.90.20	Accounting machines
58	8470.90.90	Other
	8471.30.10	Handheld computers including palmtops and personal digital assistants (PDAs)
	8471.30.20	Laptops including notebooks and subnotebooks
61	8471.30.90	Other

No	AHTN 2012	Description
NO	ATTN 2012	· ·
62	8471.41.10	Personal computers excluding portable computers of subheading 8471.30
63	8471.41.90	Other
64	8471.49.10	Personal computers excluding portable computers of subheading 8471.30
65	8471.49.90	Other
66	8471.50.10	Processing units for personal (including portable) computers
	8471.50.90	Other
	8471.60.30	Computer keyboards
69	8471.60.40	X-Y coordinate input devices, including mouses, light pens, joysticks, track balls, and touch sensitive screens
70	8471.60.90	Other
	8471.70.10	Floppy disk drives
	8471.70.20	Hard disk drives
	8471.70.30	Tape drives
	8471.70.40	Optical disk drives, including CD-ROM drives, DVD drives and CD-R drives
75	8471.70.50	Proprietary format storage devices including media therefor for automatic data processing machines, with or without removable media and whether magnetic, optical or other technology
76	8471.70.91	Automated backup systems
77	8471.70.99	Other
78	8471.80.10	Control and adaptor units
79	8471.80.70	Sound cards or video cards
80	8471.80.90	Other
81	8471.90.10	Bar code readers
82	8471.90.20	Optical character readers, document or image scanners
83	8471.90.90	Other
84	8472.90.10	Automatic teller machines
85	8473.10.10	Printed circuit assemblies for word-processing machines
86	8473.21.00	Of the electronic calculating machines of subheading 8470.10.00, 8470.21.00 or 8470.29.00
87	8473.29.00	Other
-	8473.30.10	Assembled printed circuit boards
	8473.30.90	Other
	8473.40.11	Parts, including printed circuit assemblies for automatic teller machines
91	8473.40.20	For non-electrically operated machines
	8473.50.11	Suitable for use with the machines of heading 84.71
-	8473.50.19	Other
	8473.50.20	For non-electrically operated machines
	8477.80.31	Lamination presses for the manufacture of printed circuit boards or printed wiring boards
96	8477.90.32	Parts of lamination presses for the manufacture of printed circuit boards or printed wiring boards
97	ex8479.71.00	Of a kind used in airports, electrically operated
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No	AHTN 2012	Description
	ex8479.79.00	Other passenger boarding bridges, electrically operated
	8479.89.20	Machinery for assembling central processing unit (CPU) daughter boards in plastic cases or housings; apparatus for the regeneration of chemical solutions used in the manufacture of printed circuit boards or printed wiring boards; equipment for mechanically cleaning the surfaces of printed circuit boards or printed wiring boards during manufacturing; automated machines for the placement or the removal of components or contact elements on printed circuit boards or printed wiring boards or other substrates; registration equipment for the alignment of printed circuit boards or printed wiring boards or printed circuit assemblies in the manufacturing process
100	8479.89.30	
	8479.90.20	Other, electrically operated
	8486.10.10	Of goods of subheading 8479.89.20 Apparatus for rapid heating of semiconductor wafers
	8486.10.20	
	8486.10.30	 Spin dryers for semiconductor wafer processing Machines for working any material by removal of material, by laser or other light or photon beam in the production of semiconductor wafers
105	8486.10.40	Machines and apparatus for sawing monocrystal semiconductor boules into slices, or wafers into chips
106	8486.10.50	Grinding, polishing and lapping machines for processing of semiconductor wafers
107	8486.10.60	Apparatus for growing or pulling monocrystal semiconductor boules
108	8486.10.90	Other
109	8486.20.11	Chemical vapour deposition apparatus for semiconductor production
110	8486.20.12	Epitaxial deposition machines for semiconductor wafers; spinners for coating photographic emulsions on semiconductor wafers
111	8486.20.13	Apparatus for physical deposition by sputtering on semiconductor wafers; physical deposition apparatus for semiconductor production
112	8486.20.21	Ion implanters for doping semiconductor materials
113	8486.20.31	Deflash machines for cleaning and removing contaminants from the metal leads of semiconductor packages prior to the electroplating process; spraying appliances for etching, stripping or cleaning semiconductor wafers
114	8486.20.32	Equipment for dry-etching patterns on semiconductor materials
115	8486.20.33	Apparatus for wet etching, developing, stripping or cleaning semiconductor wafers
116	8486.20.39	Other
117	8486.20.41	Direct write-on-wafer apparatus
	8486.20.42	Step and repeat aligners
119	8486.20.49	Other

120 8486.20.51 Dicing machines for scribing or scoring semiconductor wafers 121 8486.20.59 Other 122 8486.20.91 Lasercutters for cutting contacting tracks in semiconductor production by laser beam 123 8486.20.92 Machines for bending, folding and straightening semiconductor leads 124 8486.20.93 Resistance heated furnaces and ovens for the manufacture of semiconductor devices on semiconductor wafers 125 8486.20.94 Inductance or dielectric furnaces and ovens for the manufacture of semiconductor devices on semiconductor wafers 126 8486.20.94 Automated machines for the placement or the removal of components or contact elements on semiconductor materials 127 8486.20.99 Other 128 8486.30.10 Apparatus for dy etching patterns on flat panel display substrates 129 8486.30.20 panel displays 130 8486.30.20 panel displays 130 8486.30.30 Apparatus for wet etching, developing, stripping or cleaning flat panel displays 131 8486.40.10 panel displays substrates; apparatus for flat panel display production; spinners for coating photosensitive emulsions on flat panel display substrates; 131 8486.40.20 automated machines for transport, handling and storage of semiconductor wafers, wafer cassettes, wafer boxes and other materials for semiconductor devices 133 8486.40.30 Moulds for emiloacture of semiconductor devices 134 8486.40.40 designed for the handling and transport of semiconductor wafers or reticles 135 8486.40.50 Photomicrographic microscopes fitted with equipment specifically designed for the handling and transport of semiconductor wafers or reticles 136 8486.40.60 Pattern generating apparatus of a kind used for producing masks or reticles from photoresist coated substrates 137 8486.40.70 Pattern generating apparatus of a kind used for producing masks or reticles from photoresist coated substrates 138 8486.90.11 Of apparatus for rapid heating of semiconductor wafers or reticles from photoresist coated substrates 139 8486.90.13 Tool holders and self-opening diehea	No	AHTN 2012	Description
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Tool holders and self-opening dieheads; work holders; dividing			
	4.15	8486.90.14	
	140		

No	AHTN 2012	Description
	8486.90.15	Other
	8486.90.16	Of grinding, polishing and lapping machines for processing of semiconductor wafers
143	8486.90.17	Of apparatus for growing or pulling monocrystal semiconductor boules
144	8486.90.21	Of chemical vapour deposition apparatus for semiconductor production
145	8486.90.23	Of ion implanters for doping semiconductor materials; of apparatus for physical deposition by sputtering on semiconductor wafers; of physical deposition apparatus for semiconductor production; of direct write-on-wafer apparatus, step and repeat aligners and other lithography equipment
146	8486.90.24	Tool holders and self-opening dieheads; work holders; dividing heads and other special attachments for machine tools
147	8486.90.25	Other
	8486.90.26	 Tool holders and self-opening dieheads; workholders; dividing heads and other special attachments for machine tools
149	8486.90.27	Other
150	8486.90.28	Of resistance heated furnaces and ovens for the manufacture of semiconductor devices on semiconductor wafers; of inductance or dielectric furnaces and ovens for the manufacture of semiconductor devices on semiconductor wafers
151	8486.90.29	Other
152	8486.90.31	Of apparatus for dry etching patterns on flat panel display substrates
153	8486.90.32	Tool holders and self-opening dieheads; work holders; dividing heads and other special attachments for machine tools
154	8486.90.33	Other
155	8486.90.34	Of chemical vapour deposition apparatus for flat panel display production
156	8486.90.36	Of apparatus for physical deposition on flat panel display substrates
157	8486.90.41	Of focused ion beam milling machine to produce or repair masks and reticles for patterns on semiconductor devices
158	8486.90.42	Of die attach apparatus, tape automated bonders, wire bonders and of encapsulation equipment for assembly of semiconductors
159	8486.90.43	 Of automated machines for the transport, handling and storage of semiconductor wafers, wafer cassettes, wafer boxes and other materials for semiconductor devices
160	8486.90.44	Of optical stereoscopic and photomicrographic microscopes fitted with equipment specifically designed for the handling and transport of semiconductor wafers or reticles
161	8486.90.45	 Of electron beam microscopes fitted with equipment specifically designed for the handling and transport of semiconductor wafers or reticles

No	AHTN 2012	Description
162	8486.90.46	Of pattern generating apparatus of a kind used for producing masks or reticles from photoresist coated substrates, including printed circuit assemblies
	8504.40.11	Uninterrupted power supplies (UPS)
164	8504.40.19	Other
165	8504.50.10	Inductors for power supplies for automatic data processing machines and units thereof, and for telecommunications apparatus
166	8504.50.20	Chip type fixed inductors
167	8504.90.20	Printed circuit assemblies for the goods of subheading 8504.40.11, 8504.40.19 or 8504.50.10
168	8507.60.10	Of a kind used for laptops including notebooks and subnotebooks
169	8507.60.90	Other
170	8513.90.10	Parts of portable miners' helmet lamps or quarrymen's lamps, designed to function by their own source of electric energy
171	8513.90.90	Parts of portable electric lamps designed to function by their own source of energy other than of miners' helmet lamps or quarrymen's lamps; flashlight reflectors, and flashlight switch slides of plastics
172	8514.20.20	Electric furnaces or ovens for the manufacture of printed circuit boards/printed wiring boards or printed circuit assemblies
173	8514.30.20	Electric furnaces or ovens for the manufacture of printed circuit boards/printed wiring boards or printed circuit assemblies
174	8514.90.20	Parts of industrial or laboratory electric furnaces or ovens for the manufacture of printed circuit boards/printed wiring boards or printed circuit assemblies
175	8515.19.10	Machines and apparatus for soldering components on printed circuit boards/printed wiring boards
176	8515.90.20	Parts of machine apparatus for soldering components on printed circuit boards/printed wiring boards
177	8517.11.00	Line telephone sets with cordless handsets
178	8517.12.00	Telephones for cellular networks or for other wireless networks
	8517.18.00	Other
180	8517.61.00	Base stations
181	8517.62.10	Radio transmitters and radio receivers of a kind used for simultaneous interpretation at multilingual conferences
182	8517.62.21	Control and adaptor units, including gateways, bridges and routers
	8517.62.29	Other
	8517.62.30	Telephonic or telegraphic switching apparatus
	8517.62.41	Modems including cable modems and modem cards
	8517.62.42	Concentrators or multiplexers
	8517.62.49	Other
188	8517.62.51	Wireless LANs

No	AHTN 2012	Description
140	AIIIN 2012	Other transmission apparatus for radio-telephony or radio-
189	8517.62.53	1
100	8517.62.59	telegraphy Other
	8517.62.61	For radio-telephony or radio-telegraphy
192	8517.62.69	Other
193	8517.62.91	Portable receivers for calling, alerting or paging and paging alert
404	0547.00.00	devices, including pagers
	8517.62.92	For radio-telephony or radio-telegraphy
	8517.62.99	Other
196	8517.69.00	Other
197	8517.70.10	Of control and adaptor units including gateways, bridges and
100	0547.70.04	routers
	8517.70.21	Of cellular telephones
	8517.70.29	Other
	8517.70.31	Of goods for line telephony or line telegraphy
	8517.70.32	Of goods for radio-telephony or radio-telegraphy
202	8517.70.39	Other
203	8517.70.40	Aerials or antennae of a kind used with apparatus for radio-
		telephony and radio-telegraphy
	8517.70.91	Of goods for line telephony or line telegraphy
	8517.70.92	Of goods for radio-telephony or radio-telegraphy
206	8517.70.99	Other
		Microphones having a frequency range of 300 Hz to 3,400 Hz,
207	8518.10.11	with a diameter not exceeding 10 mm and a height not exceeding 3
		mm, for telecommunication use
		Loudspeakers, without enclosure, having a frequency range of
208	8518.29.20	300 Hz to 3,400 Hz, with a diameter not exceeding 50 mm, for
		telecommunication use
	8518.30.40	Line telephone handsets
	8518.40.20	Used as repeaters in line telephony
211	8518.40.30	Used as repeaters in telephony other than line telephony
212	8518.90.10	Of goods of subheading 8518.10.11, 8518.29.20, 8518.30.40 or
		8518.40.20, including printed circuit assemblies
213	8519.50.00	- Telephone answering machines
214	8519.81.10	Pocket size cassette recorders, the dimensions of which do not
	0010.01.10	exceed 170 mm x 100 mm x 45 mm
		Cassette recorders, with built in amplifiers and one or more built
215	8519.81.20	in loudspeakers, operating only with an external source of power
216	8522.90.20	Printed circuit board assemblies for telephone answering
210	0022.30.20	machines
217	8523.29.11	Computer tapes
	8523.29.19	Other
	8523.29.29	Other
220	8523.29.31	Computer tapes
	8523.29.33	Video tapes
222	8523.29.39	Other

No	AHTN 2012	Description
	8523.29.41	Computer tapes
224	8523.29.49	Other
225	8523.29.51	Computer tapes
226	8523.29.52	Video tapes
227	8523.29.59	Other
228	8523.29.61	Of a kind used for reproducing representations of instructions, data, sound and image, recorded in a machine readable binary form, and capable of being manipulated or providing interactivity to a user, by means of an automatic data processing machine; proprietary format storage (recorded) media
229	8523.29.62	Of a kind suitable for cinematography
230	8523.29.63	Other video tapes
231	8523.29.69	Other
232	8523.29.71	Computer hard disks and diskettes
233	8523.29.79	Other
234	8523.29.81	Of a kind suitable for computer use
235	8523.29.82	Other
236	8523.29.83	Other, of a kind used for reproducing representations of instructions, data, sound and image, recorded in a machine readable binary form, and capable of being manipulated or providing interactivity to a user, by means of an automatic data processing machine; proprietary format storage (recorded) media
237	8523.29.91	Of a kind suitable for computer use
238	8523.29.92	Other
239	8523.29.93	Of a kind suitable for computer use
240	8523.29.94	Other
241	8523.29.95	Other, of a kind used for reproducing representations of instructions, data, sound and image, recorded in a machine readable binary form, and capable of being manipulated or providing interactivity to a user, by means of an automatic data processing machine; proprietary format storage (recorded) media
242	8523.29.99	Other
243	8523.41.10	Of a kind suitable for computer use
244	8523.41.90	Other
245	8523.49.11	Of a kind used for reproducing phenomena other than sound or image
246	8523.49.14	Other, of a kind used for reproducing representations of instructions, data, sound and image, recorded in a machine readable binary form, and capable of being manipulated or providing interactivity to a user, by means of an automatic data processing machine; proprietary format storage (recorded) media

No	AHTN 2012	Description
No	ANTIN ZUTZ	Description Of a kind yeard for reproducing the page 2 at her then accord on
248	8523.49.91	Of a kind used for reproducing phenomena other than sound or image
249	8523.49.93	Other, of a kind used for reproducing representations of instructions, data, sound and image, recorded in a machine readable binary form, and capable of being manipulated or providing interactivity to a user, by means of an automatic data processing machine; proprietary format storage (recorded) media
250	8523.49.99	Other
251	8523.51.11	Of a kind suitable for computer use
252	8523.51.19	Other
253	8523.51.21	Of a kind suitable for computer use
254	8523.51.29	Other
255	8523.51.30	Other, of a kind used for reproducing representations of instructions, data, sound and image, recorded in a machine readable binary form, and capable of being manipulated or providing interactivity to a user, by means of an automatic data processing machine; proprietary format storage (recorded) media
256	8523.51.90	Other
257	8523.52.00	"Smart cards"
258	8523.59.10	Proximity cards and tags
259	8523.59.21	Of a kind suitable for computer use
260	8523.59.29	Other
261	8523.59.30	Of a kind used for reproducing phenomena other than sound or image
262	8523.59.40	Other, of a kind used for reproducing representations of instructions, data, sound and image, recorded in a machine readable binary form, and capable of being manipulated or providing interactivity to a user, by means of an automatic data processing machine; proprietary format storage (recorded) media
263	8523.59.90	Other
	8523.80.51	Of a kind suitable for computer use
	8523.80.59	Other
	8523.80.91	Of a kind used for reproducing phenomena other than sound or image
267	8523.80.92	Other, of a kind used for reproducing representations of instructions, data, sound and image, recorded in a machine readable binary form, and capable of being manipulated or providing interactivity to a user, by means of an automatic data processing machine; proprietary format storage (recorded) media
268	8523.80.99	Other
269	8525.60.00	- Transmission apparatus incorporating reception apparatus
270	8525.80.10	Web cameras
271	8525.80.31	Of a kind used in broadcasting

No	AHTN 2012	Description
	8525.80.39	Other
	8525.80.50	Other digital cameras
273	0323.00.30	Radar apparatus, ground based, or of a kind for use in civil
274	8526.10.10	aircraft, or of a kind used solely on sea-going vessels
		Radio navigational aid apparatus, of a kind for use in civil aircraft,
275	8526.91.10	
276	0507.40.44	or of a kind used solely on sea-going vessels Portable
	8527.19.11	
	8527.19.19	Other
	8528.41.10	Colour
	8528.41.20	Monochrome
	8528.49.10	Colour
	8528.51.10	Projection type flat panel display units
	8528.51.20	Other, colour
	8528.51.30	Other, monochrome
	8528.59.10	Colour
	8528.61.10	Flat panel display type
286	8528.61.90	Other
287	8528.69.10	Having the capability of projecting on a screen of 300 inches or more
288	8528.69.90	Other
289	8528.71.11	Mains operated
290	8528.71.19	Other
291	8529.10.40	Aerial filters and separators
292	8529.90.20	Of decoders
293	8529.90.40	Of digital cameras or video camera recorders
294	8529.90.51	For goods of subheading 8525.50 or 8525.60
005	0500 00 50	For goods of subheading 8527.13, 8527.19, 8527.21, 8527.29,
295	8529.90.52	8527.91 or 8527.99
296	8529.90.53	For flat panel displays
297	8529.90.54	Other, for television receivers
-	8529.90.55	Other
299	8529.90.59	Other
	8529.90.91	For television receivers
	8529.90.94	For flat panel displays
302	8529.90.99	Other
	8531.20.00	- Indicator panels incorporating liquid crystal devices (LCD) or light emitting diodes (LED)
304	8531.80.21	Vacuum fluorescent display panels
	8531.80.29	Other
	8531.90.10	Parts including printed circuit assemblies of subheading 8531.20, 8531.80.21 or 8531.80.29
207	8532.21.00	Tantalum
	8532.22.00	Aluminium electrolytic
	8532.23.00	Ceramic dielectric, single layer
	8532.24.00	Ceramic dielectric, multilayer
	8532.25.00	Dielectric of paper or plastics
312	8532.29.00	Other

No	AHTN 2012	Description
_	8532.30.00	- Variable or adjustable (pre-set) capacitors
	8532.90.00	- Parts
	8533.10.10	Surface mounted
	8533.10.90	Other
	8533.21.00	For a power handling capacity not exceeding 20 W
	8533.31.00	For a power handling capacity not exceeding 20 W
319	8533.39.00	Other
320	8533.40.00	- Other variable resistors, including rheostats and potentiometers
321	8533.90.00	- Parts
322	8534.00.10	- Single-sided
323	8534.00.20	- Double-sided
324	8534.00.30	- Multi-layer
325	8534.00.90	- Other
326	8536.50.51	For a current of less than 16 A
327	8536.50.59	Other
328	8536.69.32	For a current of less than 16 A
329	8536.69.39	Other
330	8536.90.12	For a current of less than 16 A
331	8536.90.19	Other
332	8537.10.20	Distribution boards (including back panels and back planes) for use solely or principally with goods of heading 84.71, 85.17 or 85.25
333	8537.10.30	Programmable logic controllers for automated machines for transport, handling and storage of dies for semiconductor devices
334	8538.10.11	Parts of programmable logic controllers for automated machines for transport, handling and storage of dies for semiconductor devices
335	8538.10.21	Parts of programmable logic controllers for automated machines for transport, handling and storage of dies for semiconductor devices
336	8538.90.12	Parts of goods of subheading 8536.50.51, 8536.50.59, 8536.69.32, 8536.69.39, 8536.90.12 or 8536.90.19
337	8538.90.13	Parts of goods of subheading 8537.10.20
338	8540.40.10	Data/graphic display tubes, colour, of a kind used for articles of heading 85.25
339	ex8540.40.90	Data/graphic display tubes, colour, with a phosphor dot screen pitch smaller than 0.4 mm, other than for use with articles of heading 85.25
340	8541.10.00	- Diodes, other than photosensitive or light emitting diodes
341	8541.21.00	With a dissipation rate of less than 1 W
342	8541.29.00	Other
343	8541.30.00	- Thyristors, diacs and triacs, other than photosensitive devices
344	8541.40.10	Light emitting diodes
	8541.40.21	Photovoltaic cells, not assembled

No	AHTN 2012	Description
346	8541.40.22	Photovoltaic cells assembled in modules or made up into panels
347	8541.40.29	Other
	8541.40.90	Other
	8541.50.00	- Other semiconductor devices
	8541.60.00	- Mounted piezo-electric crystals
	8541.90.00	- Parts
352	8542.31.00	Processors and controllers, whether or not combined with memories, converters, logic circuits, amplifiers, clock and timing circuits, or other circuits
353	8542.32.00	Memories
354	8542.33.00	Amplifiers
355	8542.39.00	Other
356	8542.90.00	- Parts
357	8543.30.20	Wet processing equipment for the application by immersion of chemical or electrochemical solutions, whether or not for the purpose of removing material on printed circuit board/printed wiring board substrates
358	8543.70.30	Electrical machines and apparatus with translation or dictionary functions
359	8543.70.40	Equipment for the removal of dust particles or the elimination of electrostatic charge during the manufacture of printed circuit boards/printed wiring boards or printed circuit assemblies; machines for curing material by ultra-violet light for the manufacture of printed circuit boards/printed wiring boards or printed circuit assemblies
360	8543.90.20	Of goods of subheading 8543.30.20
361	8543.90.30	Of goods of subheading 8543.70.30
362	8543.90.40	Of goods of subheading 8543.70.40
363	8543.90.90	Other
364	8544.42.11	Telephone, telegraph and radio relay cables, submarine
365	8544.42.12	Telephone, telegraph and radio relay cables, other
366	8544.42.19	Other
	8544.42.21	Telephone, telegraph and radio relay cables, submarine
368	8544.42.22	Telephone, telegraph and radio relay cables, other
369	8544.42.29	Other
370	8544.49.11	Telephone, telegraph and radio relay cables, submarine
371	8544.49.12	Telephone, telegraph and radio relay cables, other
372	8544.49.19	Other
373	8544.70.10	Telephone, telegraph and radio relay cables, submarine
374	8544.70.90	Other
375	8548.90.10	Image sensors of the contact type comprising a photo-conductive sensor element, an electric charge storage condenser, a light source of light emitting diodes, thin-film transistor matrix and a scanning condenser, capable of scanning text

No	AHTN 2012	Description
		Printed circuit assemblies including such assemblies for external
376	8548.90.20	connections
377	8548.90.90	Other
378	8803.90.10	Of telecommunications satellites
379	9006.10.10	Laser photoplotters
380	9006.91.10	For laser photoplotters of subheading 9006.10.10
	9010.50.10	Apparatus for the projection or drawing of circuit patterns on
381		sensitized substrates for the manufacture of printed circuit
		boards/printed wiring boards
	9010.90.30	Parts and accessories of apparatus for the projection or drawing of
382		circuit patterns on sensitized substrates for the manufacture of
		printed circuit boards/printed wiring boards
	9013.80.10	Optical error verification and repair apparatus for printed circuit
383		boards/printed wiring boards and printed circuit assemblies
		·
	9013.80.20	Liquid crystal devices
	9013.90.10	Of goods of subheading 9013.20
	9013.90.50	- Of goods of subheading 9013.80.20
	9013.90.60	Of goods of subheading 9013.80.10
388	9013.90.90	Other Of a kind used on abine incorporating or working in conjugation
389	9014.80.10	Of a kind used on ships, incorporating or working in conjunction with an automatic data processing machine
390	9014.90.10	Of instruments and apparatus, of a kind used on ships, working in
		conjunction with an automatic data processing machine
391	9017.10.10	Plotters
	9017.20.30	Apparatus for the projection or drawing of circuit patterns on
392		sensitized substrates for the manufacture of printed circuit
		boards/printed wiring boards
202	9017.20.40	Photoplotters for the manufacture of printed circuit boards/printed
393	9017.20.40	wiring boards
394	9017.20.50	Other plotters
		Parts and accessories of apparatus for the projection or drawing of
395	9017.90.20	circuit patterns on sensitized substrates for the manufacture of
		printed circuit boards/printed wiring boards
396	9017.90.30	Parts and accessories of photoplotters for the manufacture of
	0017100100	printed circuit boards/printed wiring boards
397	9017.90.40	Parts and accessories, including printed circuit assemblies, of
	0011100110	other plotters
398	9022.19.10	X-ray apparatus for the physical inspection of solder joints on
<u> </u>	0022.10.10	printed circuit board/printed wiring board assemblies
399	9022.90.10	Parts and accessories of X-ray apparatus for the physical
		inspection of solder joints on printed circuit assemblies
	9026.10.10	Level gauges for motor vehicles, electrically operated
	9026.10.20	Level gauges for motor vehicles, not electrically operated
	9026.10.30	Other, electrically operated
403	9026.10.90	Other, not electrically operated

No	AHTN 2012	Description
	9026.20.10	Pressure gauges for motor vehicles, electrically operated
	9026.20.20	Pressure gauges for motor vehicles, not electrically operated
	9026.20.30	- Other, electrically operated
	9026.20.40	- Other, not electrically operated
	9026.80.10	Electrically operated
	9026.80.20	Not electrically operated
	9026.90.10	For electrically operated instruments and apparatus
	9026.90.20	For non-electrically operated instruments and apparatus
	9027.20.10	Electrically operated
	9027.20.20	Not electrically operated
	9027.30.10	Electrically operated
	9027.30.20	Not electrically operated
	9027.50.10	Electrically operated
	9027.50.20	Not electrically operated
	9027.80.30	- Other, electrically operated
	9027.80.40	- Other, not electrically operated
	00=1100110	Parts and accessories, including printed circuit assemblies for
420	9027.90.10	products of heading 90.27, other than for gas or smoke analysis
		apparatus or microtomes
		Instruments and apparatus for measuring or checking voltage,
421	9030.33.10	current, resistance or power on printed circuit boards/printed wiring
		boards or printed circuit assemblies
		Impedance-measuring instruments and apparatus designed to
	9030.33.20	provide visual and/or audible warning of electrostatic discharge
422		conditions that can damage electronic circuits; apparatus for testing
		electrostatic control equipment and electrostatic grounding
		devices/fixtures
		- Other instruments and apparatus, specially designed for
423	9030.40.00	telecommunications (for example, cross-talk meters, gain measuring
		instruments, distortion factor meters, psophometers)
424	9030.82.10	Wafer probers
425	9030.82.90	Other
		Instruments and apparatus for measuring or checking electrical
426	9030.84.10	quantities on printed circuit boards/printed wiring boards and printed
		circuit assemblies
	9030.89.10	Instruments and apparatus, without a recording device, for
427		measuring or checking electrical quantities on printed circuit
721		boards/printed wiring boards and printed circuit assemblies, other
		than those covered within subheading 9030.39
	9030.90.30	Parts and accessories of optical instruments and appliances for
428		measuring or checking printed circuit boards/printed wiring boards
		and printed circuit assemblies
	9030.90.40	Parts and accessories of other instruments and apparatus for
		measuring or checking electrical quantities on printed circuit
		boards/printed wiring boards and printed circuit assemblies
430	9030.90.90	Other

No	AHTN 2012	Description
431	9031.41.00	For inspecting semiconductor wafers or devices or for inspecting photomasks or reticles used in manufacturing semiconductor devices
432	9031.49.10	Optical instruments and appliances for measuring surface particulate contamination on semiconductor wafers
433	9031.49.20	Optical error verification and repair apparatus for printed circuit boards/printed wiring boards and printed circuit assemblies
434	9031.49.30	Other optical instruments and appliances for measuring or checking printed circuit boards/printed wiring boards and printed circuit assemblies
435	9031.90.11	Parts and accessories including printed circuit assemblies of optical instruments and appliances for inspecting semiconductor wafers or devices or for inspecting masks, photomasks or reticles used in manufacturing semiconductor devices; parts and accessories of optical instruments and appliances for measuring surface particulate contamination on semiconductor wafers
436	9031.90.12	Of optical error verification and repair apparatus for printed circuit boards/printed wiring boards and printed circuit assemblies
437	9031.90.13	Of other optical instruments and appliances for measuring or checking printed circuit boards/printed wiring boards and printed circuit assemblies
438	9032.89.10	Instruments and apparatus incorporating or working in conjunction with an automatic data processing machine, for automatically regulating or controlling the propulsion, ballast or cargo handling systems of ships
439	9032.89.20	Automatic instruments and apparatus for regulating or controlling chemical or electrochemical solutions in the manufacture of printed circuit boards/printed wiring boards or printed circuit assemblies
	9032.90.10	Of goods of subheading 9032.89.10
441	9032.90.20	Of goods of subheading 9032.89.20